Attorney Docket No. Serial No. SEL 253 09/837,105 Applicant LIST OF PUBLICATIONS Kimura CITED BY APPLICANT Filing Date Group April 18, 2001 U.S. PATENT DOCUMENTS *EXAMINER DOCUMENT SUB-FILING INITIAL NUMBER DATE NAME CLASS CLASS DATE FOREIGN PATENT DOCUMENTS DOCUMENT SUB-FILING NUMBER DATE NAME CLASS CLASS DATE OTHER PUBLICATIONS (Including Author, Title, Date, Pertinent Pages) 1) US Patent Application No. 09/631,067 (pending) to Kimura, including specification, claims, abstract, drawings and PTO filing D.D. receipt. EXAMINER: DATE CONSIDERED: *EXAMINER: Initial if citation considered, whether or not citation is in conformance

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LIST OF PUBLICATIONS CITED BY APPLICANT			<u>Applicant</u> Hajime KIMURA				
			<u>Filing Date</u> April 18, 2001		<u>Group</u> 2879		
U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME		CLASS	SUB- CLASS	FILING DATE
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FOREIGN PATENT DOCUMENTS							
	DOCUMENT NUMBER	DATE	NAME		CLASS	SUB- CLASS	FILING DATE
D.D.	JP 2001 - 051272	02/23/01	Semiconductor Energy Laboratory Co., Ltd.				08/11/99
OTHER PUBLICATIONS (Including Author, Title, Date, Pertinent Pages)							
English Abstract re Japanese Patent Application No. JP 2001-051272 published February 23, 2001.							
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